

<b>Notice of References Cited</b>	Application/Control No. 10/748,881		Applicant(s)/Patent Under Reexamination TUPLER ET AL.	
	Examiner Benjamin C. Lee		Art Unit 2612	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0239477	10-2005	Kim et al.	455/456.1
*	B	US-2005/0031102	02-2005	Kraus et al.	379/114.2
*	C	US-2004/0152441	08-2004	Wong, Wai-See Candy	455/404.1
*	D	US-7,119,716	10-2006	Horstemeyer, Scott A.	340/994
*	E	US-7,076,235	07-2006	Esque et al.	455/404.1
*	F	US-7,046,140	05-2006	Adamczyk et al.	340/539.18
*	G	US-7,006,822	02-2006	Kashu et al.	455/421
*	H	US-6,696,956	02-2004	Uchida et al.	340/573.1
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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